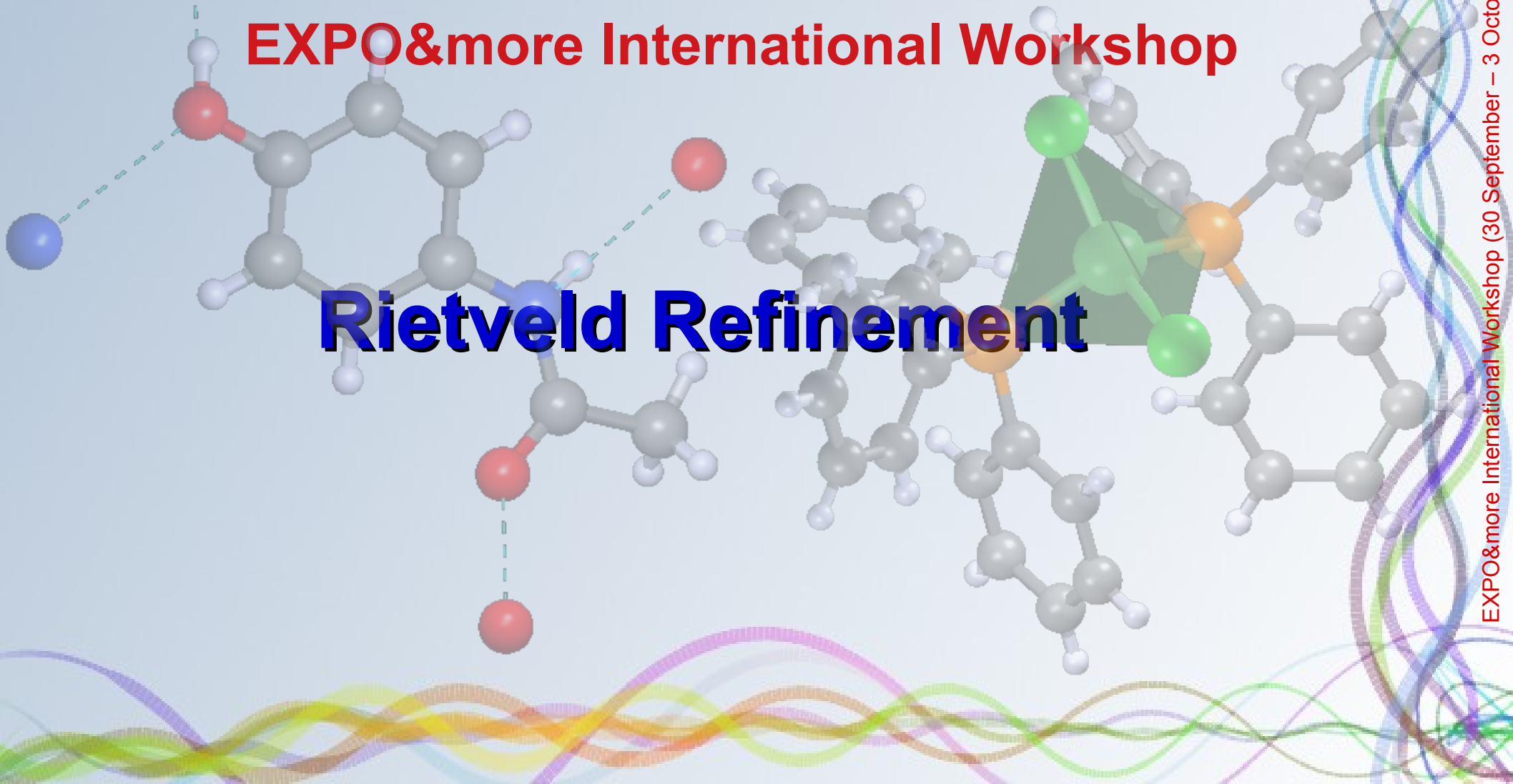




## EXPO&more International Workshop

# Rietveld Refinement



# The Rietveld Method

Based on the idea suggested in the middle **1960s** by Rietveld

## *Aim of the method*

All structural and instrumental parameters are refined by fitting a calculated profile to the observed data without extraction of the individual integrated intensities

- Nonlinear least squares method
- Requires a model of a crystal structure

# Fundamentals of the Rietveld Method

The minimized function is given by:

$$\chi^2 = \sum_{i=1}^N w_i [y_{i,obs} - y_{i,calc}]^2$$

$y_{i,obs}$  is the observed intensity at the  $i$ th data point

$y_{i,calc}$  is the calculated intensity at the  $i$ th data point

The weight is given by  $w_i = \frac{1}{y_{i,obs}}$

# Peak-Shape Functions

The diffracted profile is expressed by the equation:

$$y_{i,calc} = b_i + S \sum_{k=1}^m I_k y_k(x_k)$$

$y_{i,calc}$  is the total intensity calculated at the point  $i$

$b_i$  is the background intensity

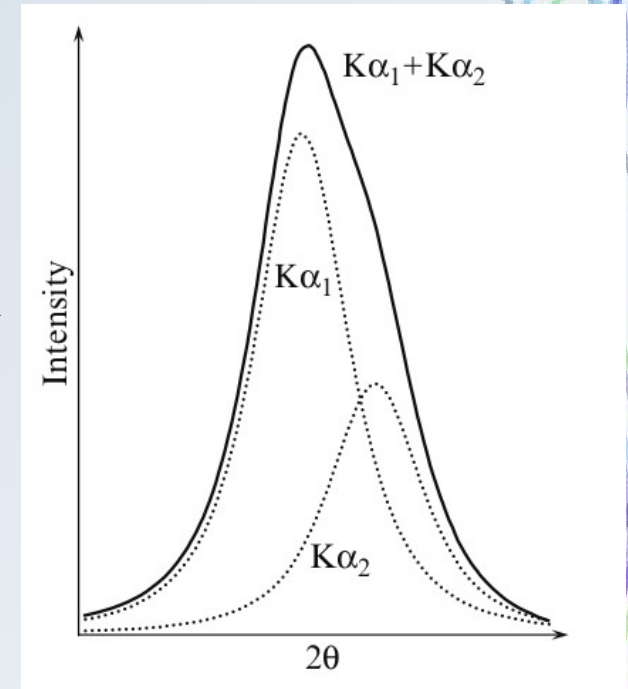
$S$  is the phase scale factor

$y_{ik}$  is the contribution from the  $k$ th individual Bragg peak

$I_k$  is the intensity of the  $k$ th Bragg reflection and the sum is extended over all  $m$  reflections contributing the intensity to point  $i$

$$x_k = 2\theta_i - 2\theta_k$$

$$y_{i,calc} = b_i + S \sum_{k=1}^m I_k [y_k(x_k) + 0.5y_k(x_k + \Delta x_k)]$$



wavelength 1.54059 1.54443 0.5

# Fundamentals of the Rietveld Method

The intensity  $I_k$  is given by the expression:

$$I_k = M_k L_k |F_k|^2 P_k$$

$M_k$  is the multiplicity

$L_k$  is the Lorentz-polarisation factor

$F_k$  is the structure factor

$P_k$  is the preferred orientation

# Fundamentals of the Rietveld Method

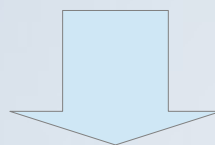
Single phase crystalline material:

$$y_{i,calc} = b_i + S \sum_{k=1}^m I_k y_{ik}$$

Mixture of several  $N_p$  phases:

$$y_{i,calc} = b_i + \sum_{p=1}^{N_p} S_p \sum_{k=1}^m I_k^p y_{ik}^p$$

For mixture of several phases, the contribution from every crystalline phase is accounted in the expression of  $y_{ci}$ .



**Quantitative analysis of a multiple phase crystalline material**

# Multiple phase powder diffraction patterns

```
%job Sample_ID_1e (Corundum 55.12%, Fluorite 29.62%, Zincite 15.25%)
```

```
%structure Sample_ID_1e
```

```
%data
```

```
pattern cpd-1e.dat
```

```
wave 1.54056 1.54439 0.5
```

```
%crystal Corundum-Al2O3.cif
```

```
%crystal Fluorite-CaF2.cif
```

```
%crystal Zincite-ZnO.cif
```

```
%rietveld
```

Rietveld Refinement

General Powder Data Corundum-Al2O3 Fluorite-CaF2 Zincite-ZnO

Automatic Procedures

- Automatic refinement of profile
- Automatic refinement of structure

Number of Cycles: 3 - +

Print Options

- start/end cycle  each cycle
- correlation matrix  LSQ matrix
- CIF

LSQ Options

Number of Cycles: 30 - + Weighting Scheme: # 2: W=1.0/Count

Criterion of Convergence: 4 - +

Refine non-structural parameters with Le Bail method

Info

Rp = 37.335 Rwp = 45.840

Refine Quit Help

# Fundamentals of the Rietveld Method

$$\chi^2 = \sum_{i=1}^N w_i [y_{i,obs} - y_{i,calc}]^2$$

$$y_{i,calc} = b_i + S \sum_{k=1}^m I_k y_{ik}$$

$$I_k = M_k L_k |F_k|^2 P_k$$

The Rietveld method is similar to the full pattern decomposition using:

- **Pawley algorithms:** the integrated intensities are treated as free least squares variables. We minimize  $\chi^2$  respect to  $|F_k|$  (non linear least-squares) or  $|F_k|^2$  (linear least-squares).
- **Le Bail algorithms:** the integrated intensities are determined iteratively after each refinement cycle



## Mathematical procedure\*

$$\chi^2 = \sum_{i=1}^N w_i [y_{i,obs} - y_{i,calc}]^2$$

$y_{i,calc}$  is a non linear function with respect to the unknown parameters,  $x_1, x_2, \dots, x_m$  and a system of equations can be assumed:

$$y_{1,calc} = M_1(x_1, x_2, \dots, x_m)$$

$$y_{2,calc} = M_2(x_1, x_2, \dots, x_m)$$

.....

$$y_{N,calc} = M_N(x_1, x_2, \dots, x_m)$$

In the matrix form:

$$\chi^2 = [\mathbf{y} - \mathbf{M}(\mathbf{x})]^T \mathbf{W} [\mathbf{y} - \mathbf{M}(\mathbf{x})]$$

# Linear Least Squares

$$\chi^2 = [\mathbf{y} - \mathbf{M}(\mathbf{x})]^T \mathbf{W} [\mathbf{y} - \mathbf{M}(\mathbf{x})]$$

$\mathbf{y}$  is the set of observable quantities  $y_{1,obs}, y_{2,obs}, \dots, y_{N,obs}$

$\mathbf{W}$  is a diagonal matrix whose diagonal elements are  $w_1, w_2, \dots, w_N$

If the model function is linear

$$\mathbf{M}(\mathbf{x}) = \mathbf{A}\mathbf{x} + \mathbf{b}$$

The set of parameters  $\mathbf{x}$  that minimizes  $\chi^2$  is the solution of normal equations

$$\mathbf{J}^T \mathbf{W} \mathbf{J} \mathbf{x} = \mathbf{J}^T \mathbf{W} (\mathbf{y} - \mathbf{b})$$

$\mathbf{J}(\mathbf{x})$  is the **Jacobian matrix**  $J(x)_{ij} = \frac{\partial M_i(x)}{\partial x_j} \quad \begin{matrix} 1 < i < N \\ 1 < j < m \end{matrix}$

Example of linear least squares: background in a polynomial approximation, phase scale, are linear,  $|F_k|^2$  in the Pawley full pattern decomposition

# Nonlinear Least Squares

Expanding the model function  $\mathbf{M}(\mathbf{x})$  around the starting point  $\mathbf{x}_0$  in Taylor's series and retaining only the linear terms we obtain the equation:

$$\mathbf{M}(\mathbf{x}) \approx \mathbf{M}(\mathbf{x}_0) + \mathbf{J}(\mathbf{x}_0)(\mathbf{x} - \mathbf{x}_0)$$

**Gauss Newton algorithm** for each  $k$  iteration

(1) Compute the search direction  $\mathbf{d}$  as the solution of the linear system

$$\mathbf{J}^T \mathbf{W} \mathbf{J} \mathbf{d} = \mathbf{J}^T \mathbf{W} [\mathbf{y} - \mathbf{M}(\mathbf{x})]$$

(2) Set  $\mathbf{x}_k = \mathbf{x}_{k-1} + \mathbf{d}$

(3) If not converged go to (1), else stop.

# Gauss-Newton-Type Methods

- Gauss-Newton method with a **line search**

$$\text{Set } \mathbf{x}_{k-1} = \mathbf{x}_k + \alpha \mathbf{d}$$

where  $\alpha$  called step length, is such that the algorithm is in descendant condition:

$$\chi^2(\mathbf{x}_k + \alpha \mathbf{d}) < \chi^2(\mathbf{x}_k)$$

is chosen by a line-search procedure

- Levenberg–Marquardt algorithm modify the normal equations in

$$(\mathbf{J}^T \mathbf{W} \mathbf{J} + \lambda \mathbf{I}) \mathbf{d} = \mathbf{J}^T \mathbf{W} [\mathbf{y} - \mathbf{M}(\mathbf{x})]$$

where  $\mathbf{I}$  is the identity matrix,  $\lambda$  is a damping factor

# Standard deviations

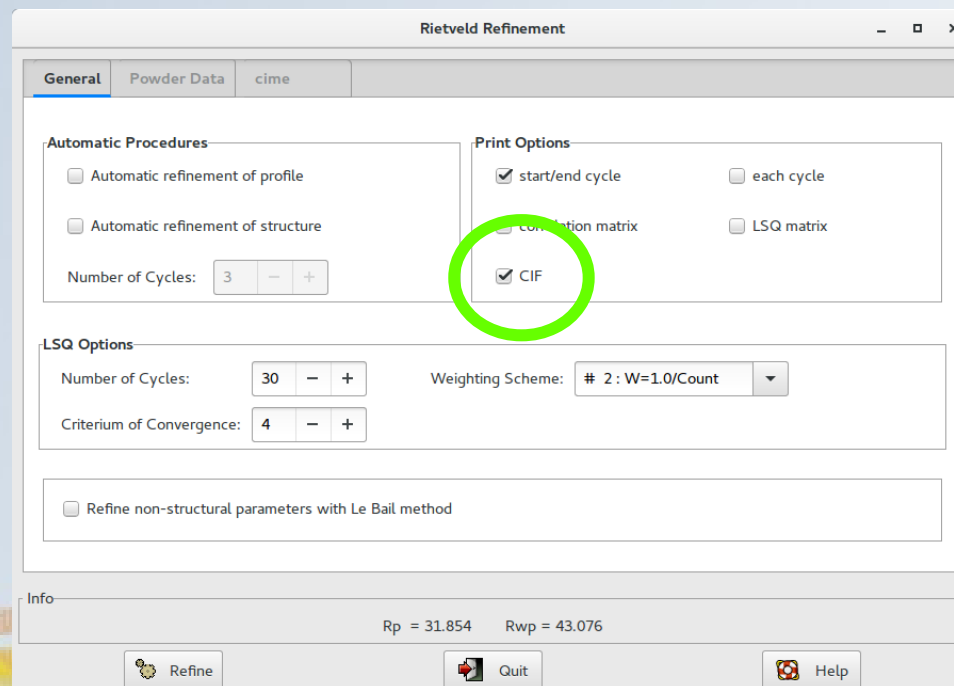
Variance-covariance matrix:  $\mathbf{V}_x = (\mathbf{J}^T \mathbf{W} \mathbf{J})^{-1}$

$$\sigma(x_j) = \sqrt{\frac{(V_x)_{jj} \chi^2}{n - m}}$$

$n$  is the number of observations

$m$  is the number of unknown parameters

$(V_x)_{jj}$  is the corresponding diagonal element of the variance-covariance matrix



# Classes of Rietveld Refinement Parameters

$$\chi^2 = \sum_{i=1}^N w_i (y_{i,obs} - [b_i + S \sum_{k=1}^m I_k y_k(x_k)])^2$$

- Background coefficients
- Sample displacement, sample transparency or zero-shift corrections
- Peak-shape function parameters
- Unit cell dimensions
- Preferred orientation
- Scale factors
- Positional parameters
- Atomic site occupancies
- Atomic displacement parameters

# Background Functions

- Polynomial function

$$b_i = \sum_{j=1}^m B_j \left( \frac{2\theta_i}{2\theta_0} - 1 \right)^{j-1}$$

where  $2\theta_0$  is the the origin of the background polynomial and  $B_j$  are the parameters to be refined

- Chebyshev polynomial

$$b_i = \sum_{j=1}^m B_j T_{j-1}(x)$$

where

$$x = \frac{2(2\theta_i - 2\theta_{min})}{2\theta_{max} - 2\theta_{min}}$$

and  $T_{j-1}(x)$  are the Chebyshev polynomials:

$$T_0(x) = 0$$

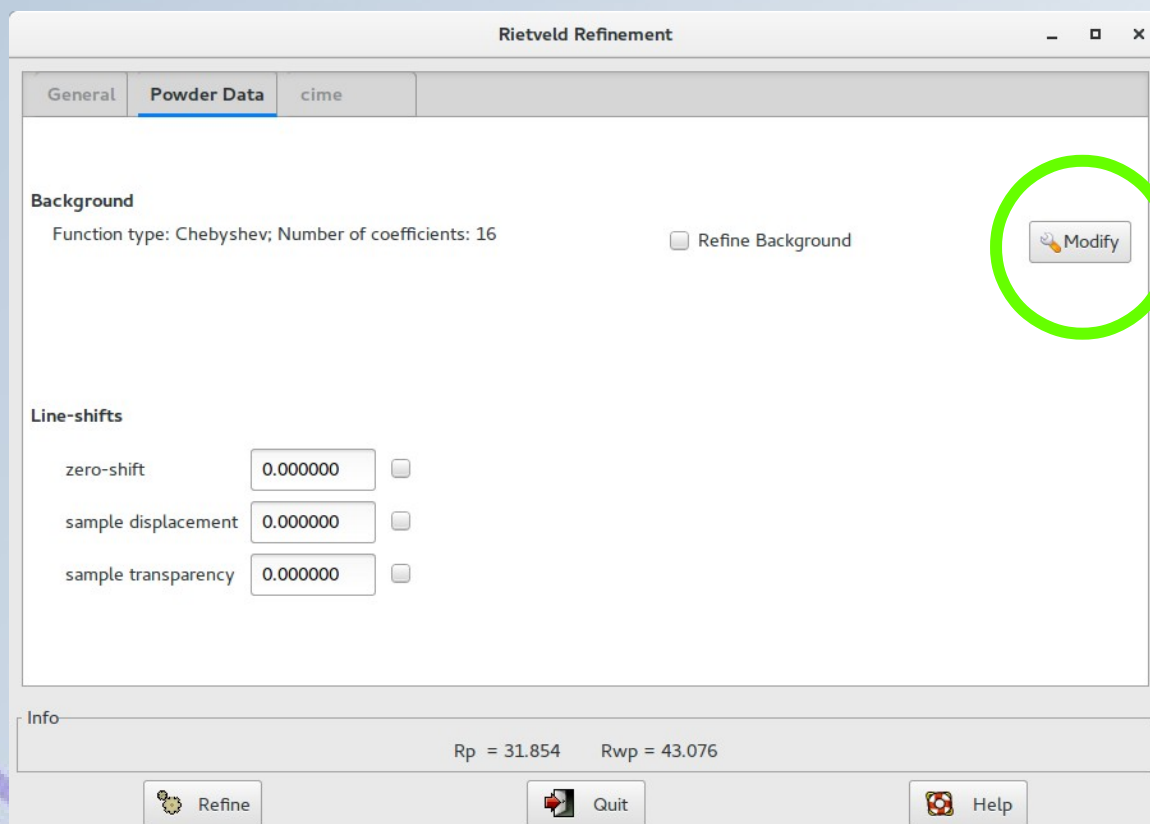
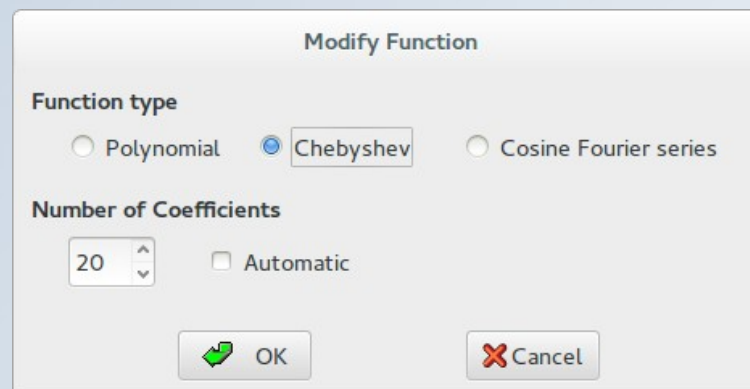
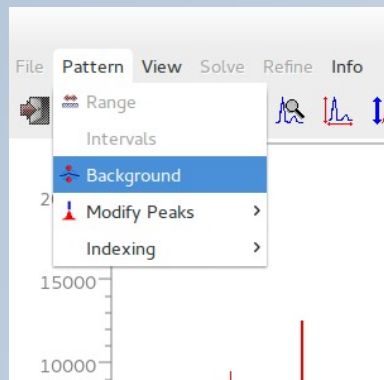
$$T_1(x) = x$$

$$T_{n+1}(x) = 2xT_n(x) - T_{n-1}(x)$$

- Cosine Fourier series

$$b_i = \sum_{j=1}^m B_j \cos(2(j-1)2\theta_i)$$

# Background function





# Peak shape functions

The screenshot shows the 'Rietveld Refinement' software window. The 'Profile function' tab is selected and highlighted with a green circle. The 'Scale factor' section shows a 'Scale' value of 0.002330. The 'Peak Shape Functions' section shows a dropdown menu set to 'Pearson VII'. Below this, there are several parameters with input fields and checkboxes: U (0.000000), V (0.000000), W (0.009845), beta0 (2.000000), beta1 (0.000000), beta2 (0.000000), asym1 (0.000000), asym2 (0.000000), asym3 (0.000000), and asym4 (0.000000). At the bottom, the 'Info' section displays 'Rp = 31.854' and 'Rwp = 43.076'. There are three buttons at the bottom: 'Refine', 'Quit', and 'Help'.

Rietveld Refinement

General Powder Data **cime**

Structure **Profile function** Corrections

Scale factor

Scale 0.002330

Peak Shape Functions

Pearson VII

U 0.000000  V 0.000000  W 0.009845

beta0 2.000000  beta1 0.000000  beta2 0.000000

asym1 0.000000  asym2 0.000000  asym3 0.000000  asym4 0.000000

Info

Rp = 31.854 Rwp = 43.076

Refine Quit Help

## Pseudo-Voigt profile function

$$y(x) = \eta \frac{C_G^{1/2}}{\sqrt{\pi}H} e^{(-C_G x^2)} + (1 - \eta) \frac{C_L^{1/2}}{\pi H} (1 + C_L x^2)^{-1}$$

$$x = \frac{(2\theta_i - 2\theta_k)}{H_k}$$

$$C_G = 4 \ln 2, C_L = 4, C_G^{1/2} / \sqrt{\pi} H \text{ with } \int_{-\infty}^{\infty} y(x) dx = 1$$

$$\eta = \eta_0 + \eta_1 2\theta + \eta_2 2\theta^2, \text{ where } 0 \leq \eta \leq 1$$

$$H = \sqrt{U \tan^2 \theta + V \tan \theta + W} \quad \text{Caglioti formula}$$

$\eta_0, \eta_1, \eta_2, U, V$  and  $W$  are refined variables

## Modified Thompson-Cox-Hastings pseudo-Voigt

$$y(x) = \eta \frac{C_G^{1/2}}{\sqrt{\pi}H} e^{(-C_G x^2)} + (1 - \eta) \frac{C_L^{1/2}}{\pi H} (1 + C_L x^2)^{-1}$$

$$H = \sum_{i=0}^5 a_i H_G^{5-i} H_L^i$$

$$H_G = \sqrt{U \tan^2 \theta + V \tan \theta + W + Z / \cos^2 \theta}$$

$$H_L = X / \cos \theta + Y \tan \theta$$

$$\eta = \sum_{i=1}^3 b_i \left( \frac{H_L}{H} \right)$$

*U, V, W, Z, X and Y are refined variables*

## Pearson-VII profile function

$$y(x) = \frac{\Gamma(\beta)}{\Gamma(\beta - 1/2)} \frac{C_p^{1/2}}{\sqrt{\pi}H} (1 - C_p x^2)^{-\beta}$$

**Default choice**

$$\beta = \beta_0 + \beta_1/2\theta + \beta_2$$

$\beta = 1$  Cauchy function

$\beta = 2$  Lorentz function

$\beta = \infty$  Gauss function

The FWHM (H) is modeled by using the **Caglioti formula** as in the case of the pseudo-Voigt function

$\beta_0, \beta_1, \beta_2, U, V, W$  are refined variables

# Peak Asymmetry

The correction for the peak asymmetry is applied by using as multiplier the semi-empirical function given in Bérar & Baldinozzi, (1993).  
J. Appl. Cryst. 26, 128-129

$$A_{ik} = 1 + P_1(\theta_k)F_a(z) + P_2(\theta_k)F_b(z)$$

$$P_1(\theta_k) = A_0/\tan(\theta_k) + A_1/\tan(2\theta_k)$$

$$P_2(\theta_k) = B_0/\tan(\theta_k) + B_1/\tan(2\theta_k)$$

$$F_a(z) = 2ze^{-z^2} \quad F_b(z) = (8z^3 - 12z)e^{-z^2} \quad z = \frac{\theta_i - \theta_k - S}{H_k}$$

$A_0, A_1, B_1,$  and  $B_2$  are refined variables

## Preferred orientation

The preferred orientation  $P_k$  is calculated using the March-Dollase function (Dollase, 1986):

$$P_k = \frac{1}{N} \sum_{i=1}^N (G^2 \cos^2 \phi_k^i + \frac{1}{G} \sin^2 \phi_k^i)^{-3/2}$$

where  $\phi_k$  is the angle between the reciprocal lattice vector  $\mathbf{d}_k^*$  corresponding to a Bragg reflection  $k$  and the reciprocal lattice vector parallel to the preferred orientation axis.

**G is the refined parameter**

## Line-shifts corrections

$$2\theta_{obs} = 2\theta_{calc} + \Delta 2\theta$$

$$\Delta 2\theta_s = -2s \frac{\cos\theta}{R} = S \cos\theta$$

Sample displacement error  
in Bragg-Brentano geometry

$$\Delta 2\theta_t = \frac{1}{2\mu R} \sin 2\theta = T \sin 2\theta$$

Transparency correction in  
Bragg-Brentano geometry

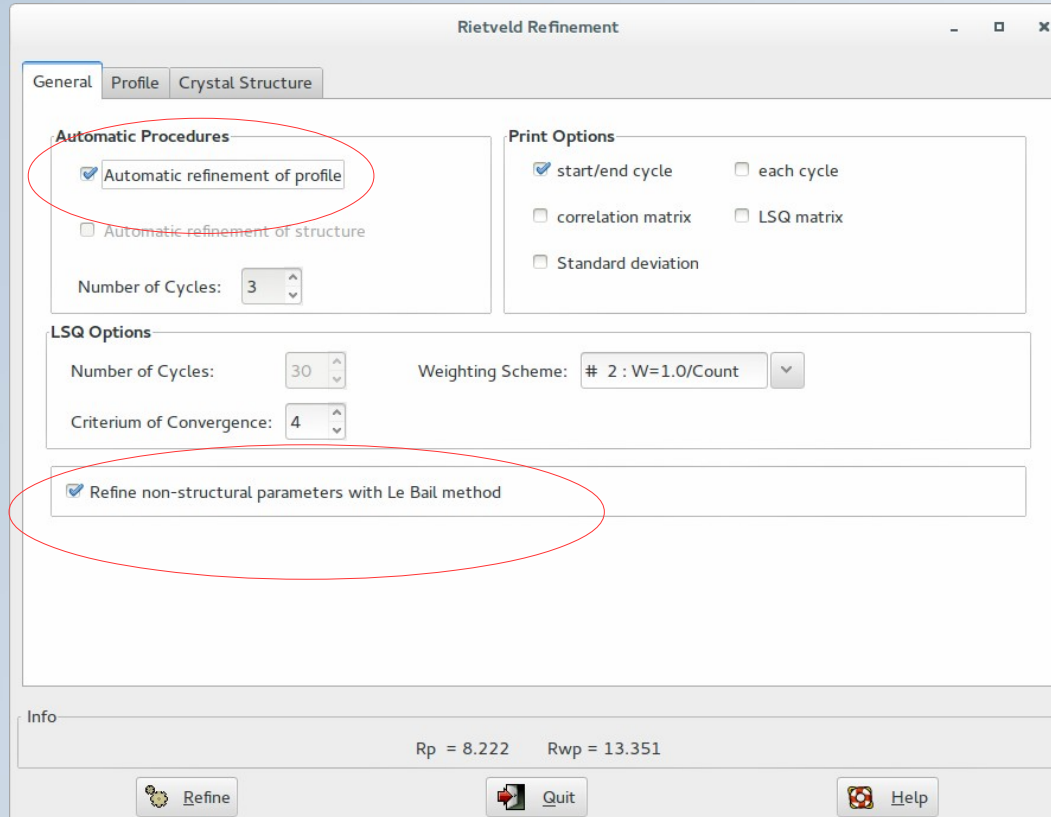
$$\Delta 2\theta = S \cos\theta + T \sin 2\theta + Z$$

The constant term  $Z$  is the zero-shift error

$S$ ,  $T$ , and  $Z$  are refined variables

# Profile parameters

The Le Bail technique can be adopted to perform a full pattern decomposition prior to Rietveld refinement



**This strategy is suggested especially if the available structure model is not completed** (Rietveld refinement guidelines, L.B. McCusker, R.B. Von Dreele, D.E. Cox, D. Louer, P. Scardi, *J. Appl. Cryst.* **32** (1999) 36)



# Refinement strategies

**The refinement can be carried out by following two alternative approaches:**

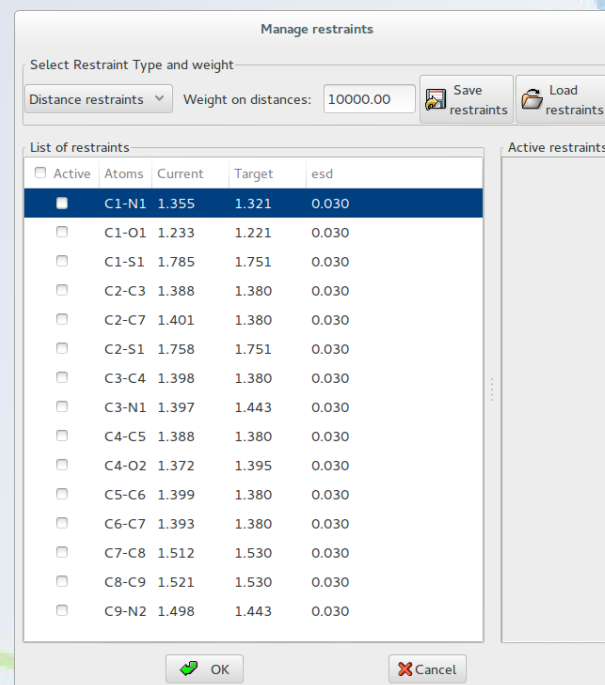
- The user can decide the refinement strategy via graphical interface
- An automatic refinement schedule can be applied
  - Scale
  - $2\theta$  correction
  - Background coefficients
  - $W$
  - $U$ ,  $V$ , other profile parameters
  - Coordinates of atoms
  - Isotropic displacements

# Restraints

$$\Phi = \sum_{i=1} w_i \cdot (y_{i,obs} - y_{i,calc})^2 + w_{dist} \sum_{i=1} w_i \cdot (dist_i^{exp} - dist_i^{calc})^2 +$$

$$w_{ang} \sum_{i=1} w_i \cdot (a_i^{exp} - a_i^{calc})^2 + w_{plane} \sum_{i=1} w_i \cdot (p_i^{exp} - p_i^{calc})^2$$

**Each type of restraints is included in the refinement as a set of observations, in addition to the main set**



Manage restraints

Select Restraint Type and weight

Distance restraints Weight on distances: 10000.00 Save restraints Load restraints

List of restraints

Active	Atoms	Current	Target	esd
<input checked="" type="checkbox"/>	C1-N1	1.355	1.321	0.030
<input type="checkbox"/>	C1-O1	1.233	1.221	0.030
<input type="checkbox"/>	C1-S1	1.785	1.751	0.030
<input type="checkbox"/>	C2-C3	1.388	1.380	0.030
<input type="checkbox"/>	C2-C7	1.401	1.380	0.030
<input type="checkbox"/>	C2-S1	1.758	1.751	0.030
<input type="checkbox"/>	C3-C4	1.398	1.380	0.030
<input type="checkbox"/>	C3-N1	1.397	1.443	0.030
<input type="checkbox"/>	C4-C5	1.388	1.380	0.030
<input type="checkbox"/>	C4-O2	1.372	1.395	0.030
<input type="checkbox"/>	C5-C6	1.399	1.380	0.030
<input type="checkbox"/>	C6-C7	1.393	1.380	0.030
<input type="checkbox"/>	C7-C8	1.512	1.530	0.030
<input type="checkbox"/>	C8-C9	1.521	1.530	0.030
<input type="checkbox"/>	C9-N2	1.498	1.443	0.030

Active restraints

OK Cancel

# Constraints

**Constraints are mathematical relationships between parameters**

**Symmetry constraints** are mandatory and automatically imposed by the program

- *Special position*

e.g., atom on special position  $(\frac{1}{2}, \frac{1}{2}, \frac{1}{2})$  should not be refined,

atom on special position  $(x, x, x)$  in space group P23 should have equal shift on x,y,z

- *Unit cell dimension*

e.g.,  $a=b=c$  and  $\alpha=\beta=\gamma$  in cubic crystal system

# Constraints

**Constraints imposed by the user** to reduce the number of parameters

- Riding model (move H atoms synchronously with the C atoms)
- Constraints on ADPs (ADPs are made to shift synchronously)
- Occupation factor  
e.g., A,B atoms in same site:  $occA + occB = 1$

# Statistical measures of a refinement

- Unweighted profile R-factor

$$R_p = \frac{\sum_i^N |y_{i,obs} - y_{i,calc}|}{\sum_i^N y_{i,obs}} \times 100$$

- Weighted profile R-factor

$$R_{wp} = \sqrt{\frac{\sum_i^N w_i \cdot (y_{i,obs} - y_{i,calc})^2}{\sum_i^N w_i \cdot (y_{i,obs})^2}} \times 100$$

## Profile residual with the background subtracted

$$R'_p = \frac{\sum_i^N |y_{i,obs} - y_{i,calc}| \cdot \frac{|y_{i,obs} - b_i|}{y_{i,obs}}}{\sum_i^N y_{i,obs} - b_i} \times 100$$

$$R'_{wp} = \sqrt{\frac{\sum_i^N w_i \cdot \left( (y_{i,obs} - y_{i,calc}) \frac{(y_{i,obs} - b_i)}{y_{i,obs}} \right)^2}{\sum_i^N w_i \cdot (y_{i,obs} - b_i)^2}} \times 100$$

# Statistical measures of a refinement

- Expected R value

$$R_{exp} = \sqrt{\frac{N - p}{\sum_i w_i \cdot (y_{i,obs})^2}} \times 100$$

- Goodness-of-fit

$$\chi^2 = \frac{\sum_i w_i \cdot (y_{i,obs} - y_{i,calc})^2}{N - P} = \left[ \frac{R_{wp}}{R_{exp}} \right]^2$$

- Other residual on  $F$  or  $F^2$ :

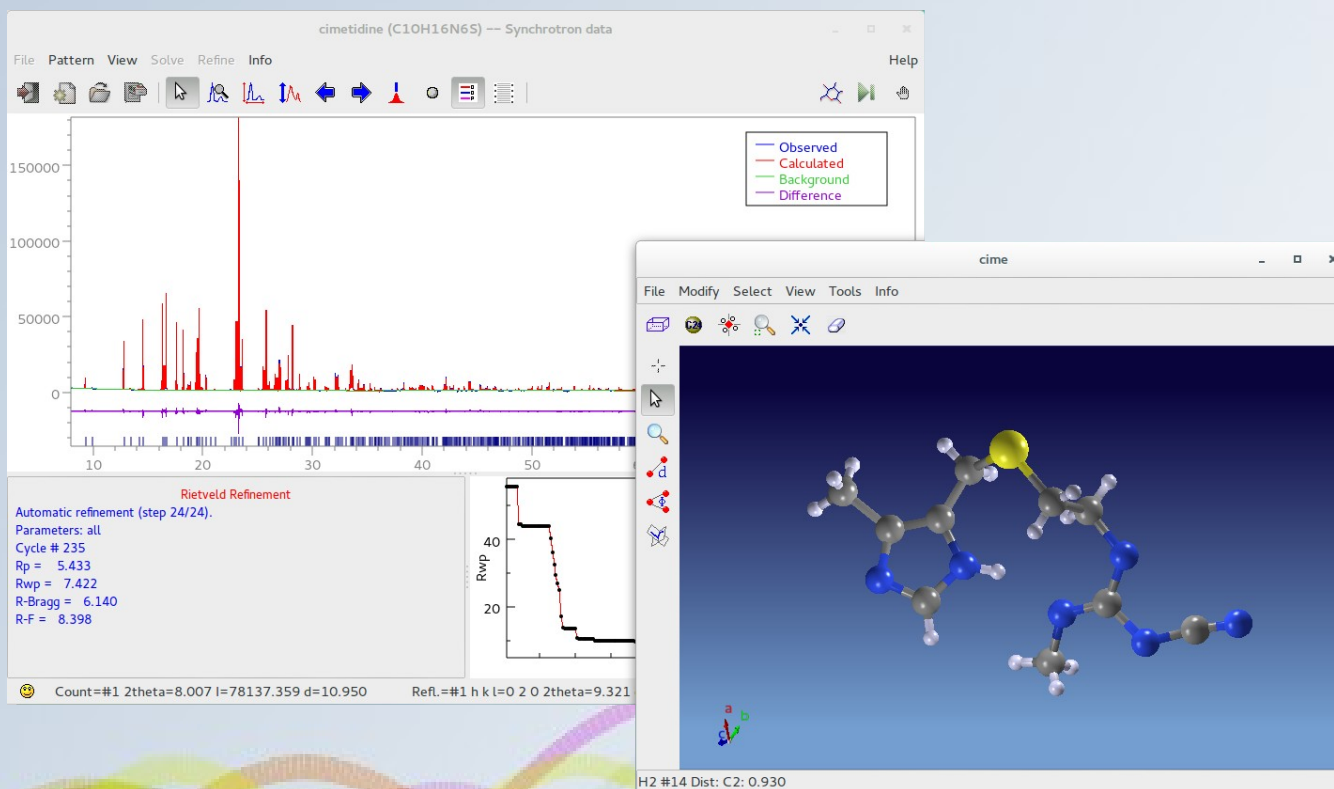
$$R_F = \frac{\sum_j^m |F_{j,obs} - F_{j,calc}|}{\sum_j^m F_{j,obs}} \times 100$$

$$R_B = \frac{\sum_j^m |I_{j,obs} - I_{j,calc}|}{\sum_j^m I_{j,obs}} \times 100$$

# Quality of refinement

## Important criteria for the quality of the refinement:

- the fit of the calculated pattern to the observed data and
- the chemical sense of the structural model

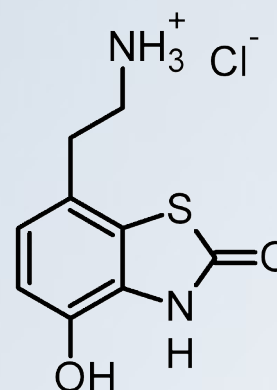




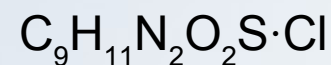
# Structure refinement of $C_9H_{11}N_2O_2S \cdot Cl$

## Input file for Rietveld refinement:

```
%Structure ammonium
%Job ethylammonium chloride (C9H11N2O2SCl)
%Data
  Pattern ammonium.xy
  Wavelength 1.54056
%crystal ammonium_riet.cif
%rietveld
```



2-(4-Hydroxy-2-oxo-2,3-dihydro-1,3-benzothiazol-7-yl)  
ethylammonium chloride



### From graphical interface:

- File > Import Diffraction Pattern
- File > Import Structure
- Refine > Rietveld

**Contact, software download and info**  
<http://www.ba.ic.cnr.it/softwareic/expo/>

## **Acknowledgements**

### **Colleagues of the research team**

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